

# "Tri-3D" Tomography in FIB, SEM and TEM: Application to Polymer Nano-Composites

Y. LIU<sup>1</sup>, H. YUAN<sup>1,2</sup>,

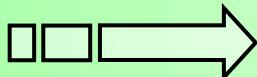
A. BOGNER-VAN DE MOORTELE<sup>1</sup>, B. VAN DE MOORTELE<sup>2</sup>,  
T. EPICIER<sup>1</sup>

<sup>1</sup>Université de Lyon, INSA-Lyon, MATEIS (CLYM), *umr CNRS 5510*, F-69621  
Villeurbanne Cedex

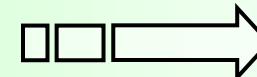
<sup>2</sup>Université de Lyon, École Normale Supérieure de Lyon, LGLTPE (CLYM),  
umr CNRS5570, 46 allée d'Italie, 69364 Lyon Cedex 07, France

# Available tomography approaches in Materials Science

$\mu\text{m}$

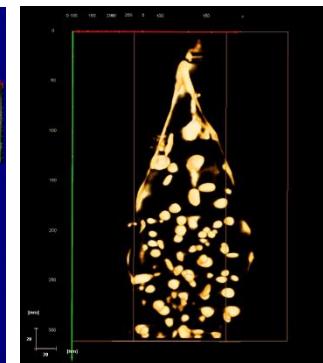
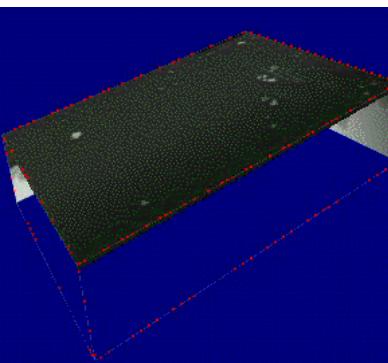


$\text{nm}$



$\text{\AA}$

## X-Ray Tomography



J.Y. BUFFIÈRES  
 (MATEIS,INSA-Lyon),  
 T. CONNOLLEY  
 (Galway, IRELAND)

A. BOGNER, Y. LIU,  
 T. EPICIER  
 (INSA-Lyon)

CLYM: B. VAN DE MOORTELE  
 (ENS-Lyon), A. DESCAMPS  
 (INSA-Lyon), N. BLANCHARD  
 (Lyon 1 University),  
 T. DOUILlard, T. EPICIER  
 (INSA-Lyon)

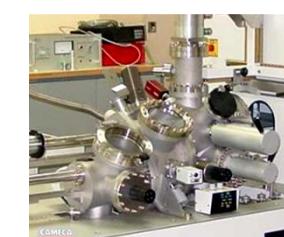
S. BENLEKBIR,  
 T. EPICIER, (MATEIS,  
 INSA-Lyon), F. DANOIX  
 (GPM-Rouen)

F. DANOIX (GPM-  
 Rouen), M. PEREZ,  
 T. EPICIER (MATEIS,  
 INSA-Lyon),  
 F. DE GEUSER,  
 A. DESCHAMPS  
 (SIMAP-Grenoble)

## SEM / FIB



## TEM

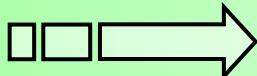


## Atom Probe Tomography / Field-Ion Microscopy

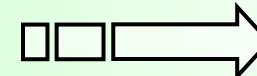


# Available tomography approaches in Materials Science

$\mu\text{m}$

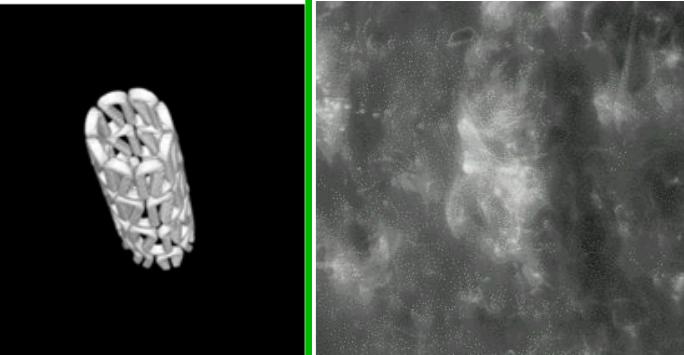


$\text{nm}$



$\text{\AA}$

## X-Ray Tomography



J.Y. BUFFIÈRES  
 (MATEIS,INSA-Lyon),  
 T. CONNOLLEY  
 (Galway, IRELAND)

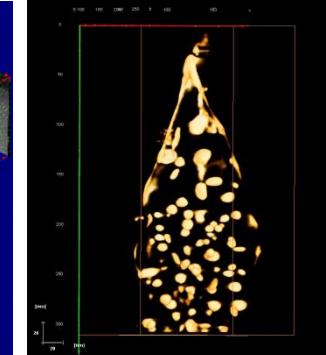
## SEM / FIB



A. BOGNER, Y. LIU,  
 T. EPICIER  
 (INSA-Lyon)

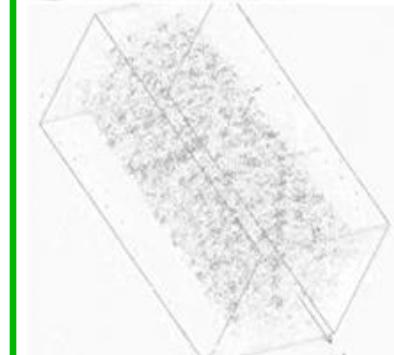
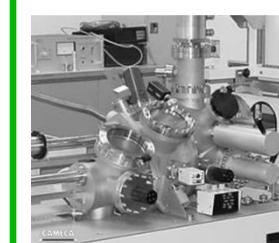
$\text{nm}$

## TEM



CLYM: B. VAN DE MOORTELE  
 (ENS-Lyon), A. DESCAMPS  
 (INSA-Lyon), N. BLANCHARD  
 (Lyon 1 University),  
 T. DOUILlard, T. EPICIER  
 (INSA-Lyon)

## Atom Probe Tomography / Field-Ion Microscopy



S. BENLEKBIR,  
 T. EPICIER, (MATEIS,  
 INSA-Lyon), F. DANOIX  
 (GPM-Rouen)

F. DANOIX (GPM-  
 Rouen), M. PEREZ,  
 T. EPICIER (MATEIS,  
 INSA-Lyon),  
 F. DE GEUSER,  
 A. DESCHAMPS  
 (SIMAP-Grenoble)

**Multi-scale approach developed at MATEIS**

# OUTLINE

## I. Materials and Techniques

### I.1 Polymer-based nano-composites

### I.2 Studied system: PMMA/PSBuA – SiO<sub>2</sub>

## II. Polymers and charged particles...

### II.1 The shrinkage effect

### II.2 Electron-induced mass-loss

## III. A Tri-3D approach of polymer nanocomposites

### III.1 FIB tomography

### III.2 Tilting tomography in LOW VOLTAGE STEM in a SEM

### III.3 Tilting tomography in TEM

## IV. Conclusion

# I. Materials and Techniques

## I.1 Polymer-based nano-composites

ancient  
Maya's  
paintings

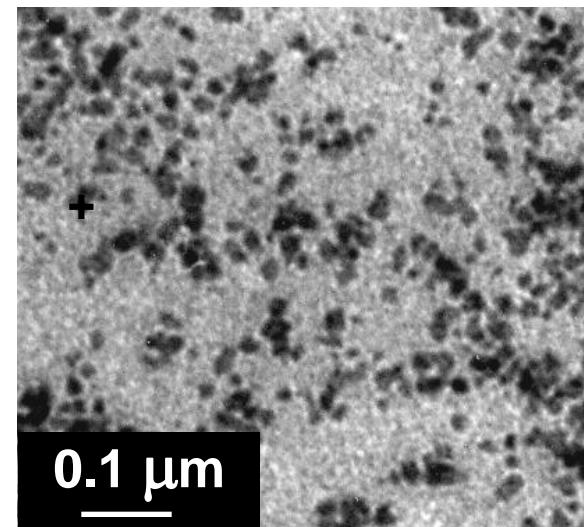


1917

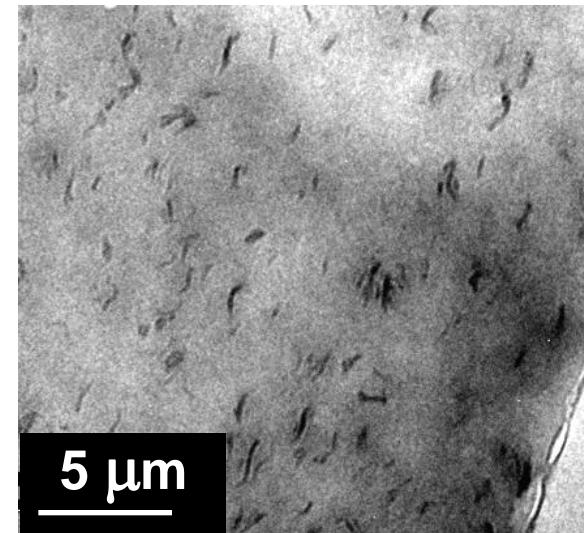


1990's

PHEMA,  
5% SiO<sub>2</sub>

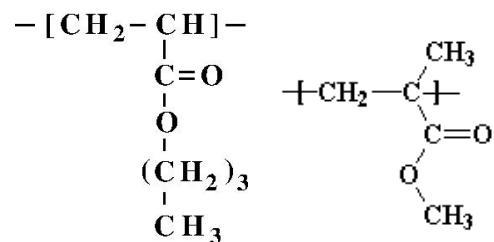


Montmorillonite  
in polyamide 6  
 $(\text{Na,Ca})_{0,3} (\text{Al,Mg})_2 \text{Si}_4 \text{O}_{10} (\text{OH})_2 n\text{H}_2\text{O}$



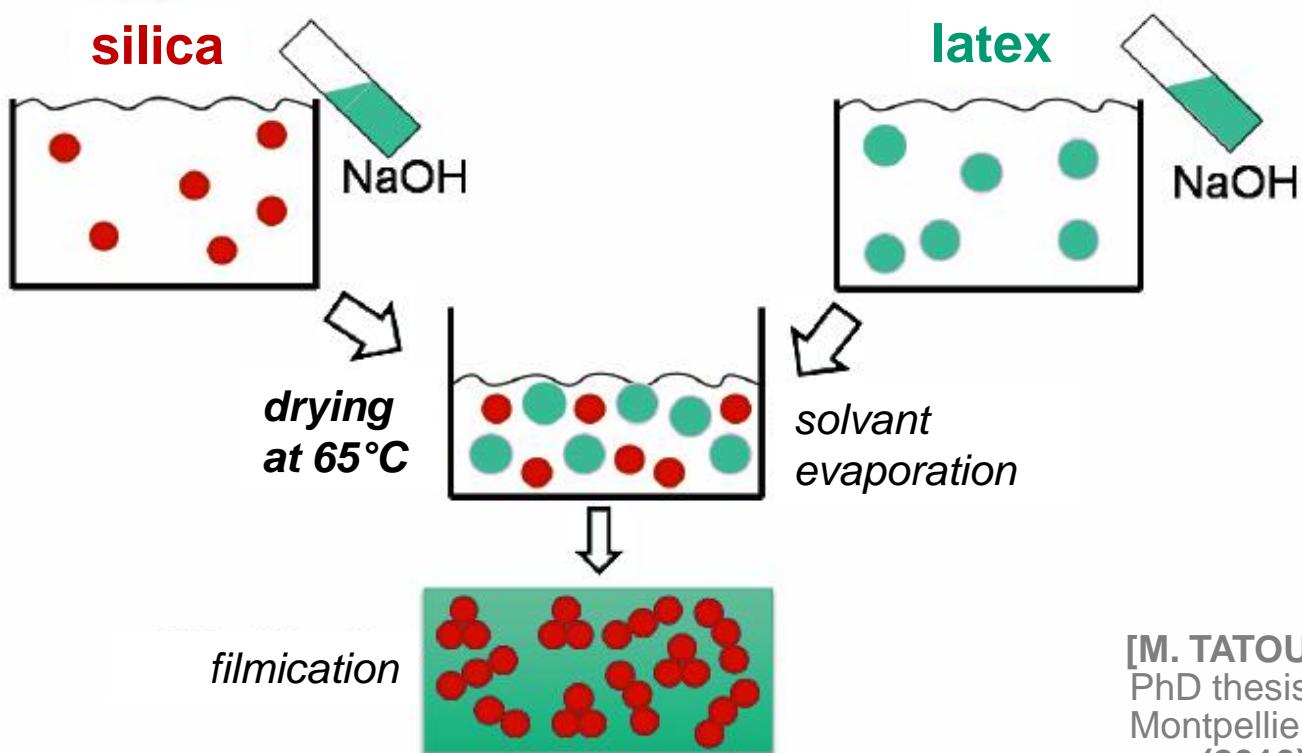
# I. Materials and Techniques

## I.2 Studied system: PMMA/PSBuA – SiO<sub>2</sub>



+

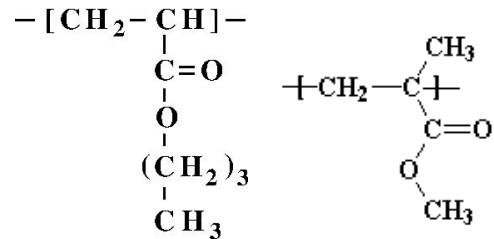
$x$  (1-5) %  
 $\text{SiO}_2$ , various PH,  
 mean NP diameter:  
 16 nm



[M. TATOU,  
 PhD thesis,  
 Montpellier,  
 (2010)]

# I. Materials and Techniques

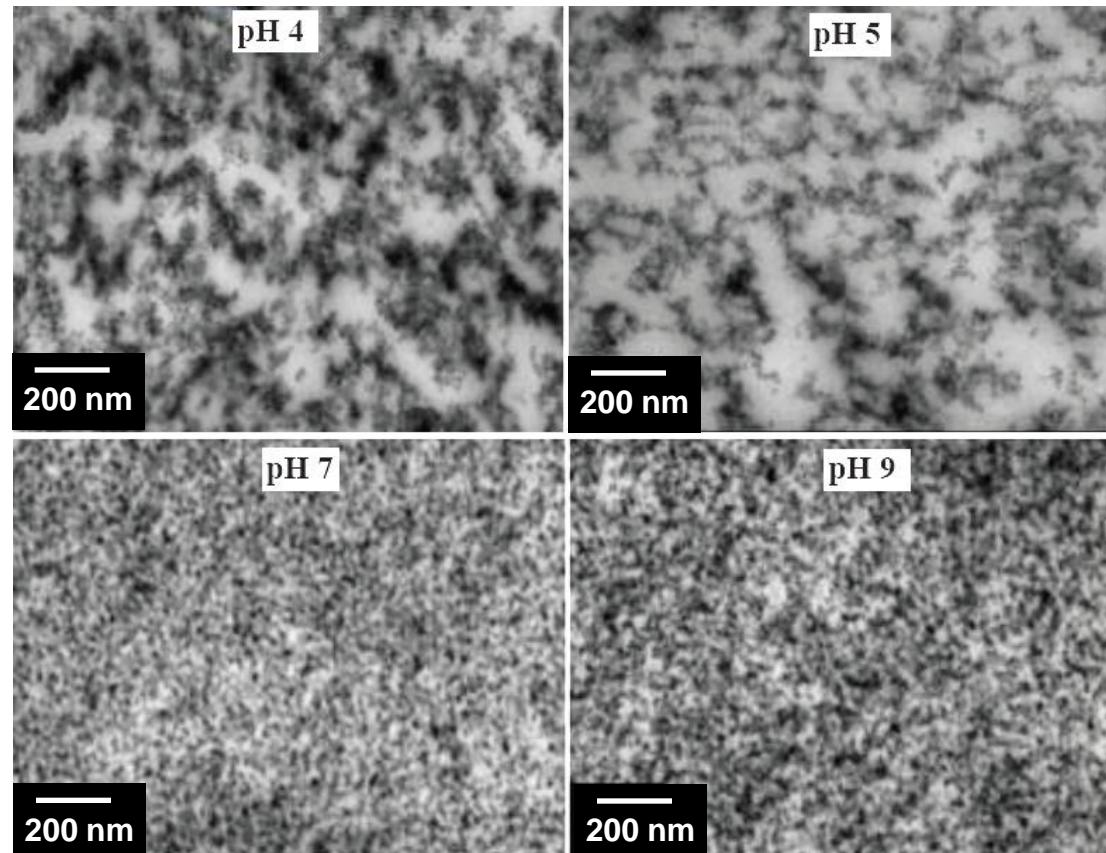
## I.1 Studied system: PMMA/PSBuA – SiO<sub>2</sub>



**BUA**      **MMA**

+

x (1-5) %  
 SiO<sub>2</sub>, various PH,  
 mean NP diameter:  
 16 nm



[M. TATOU,  
 PhD thesis,  
 Montpellier,  
 (2010)]

**TEM (120 kV)**

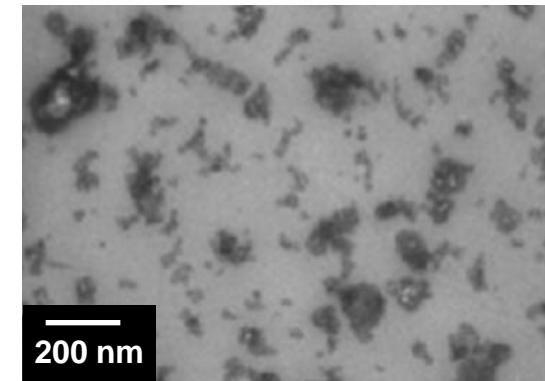
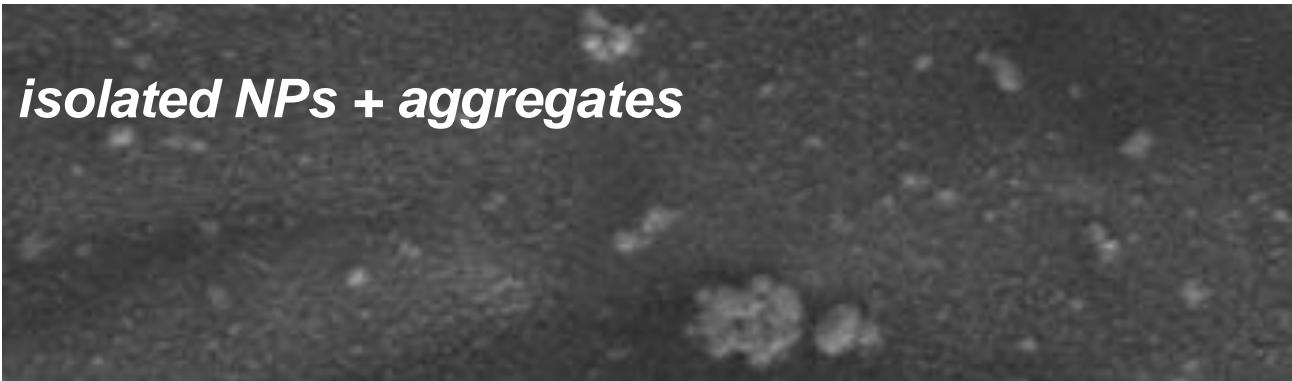
# I. Materials and Techniques

PMMA/PBuA 1% SiO<sub>2</sub>, PH5

SEM (1kV, cryo-fracture)

[M. TATOU, (2010)]  
**TEM (120 kV)**

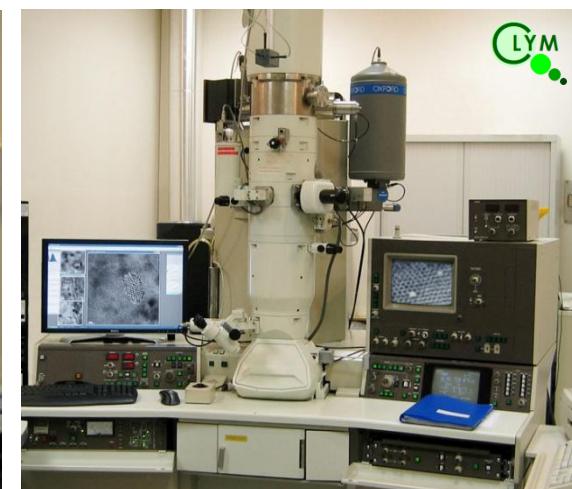
*isolated NPs + aggregates*



 **Nvision 40**  
Tomo. FIB 

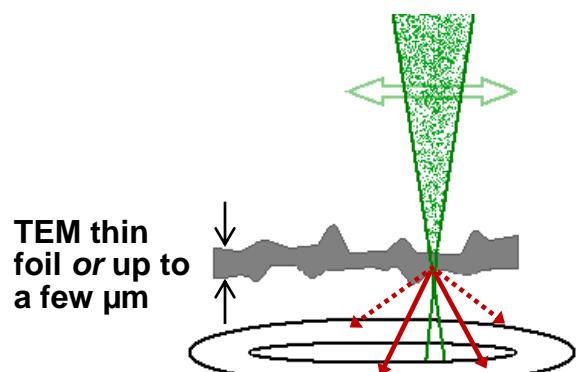


 **FEI XL30 30 kV**  
Tomo 'STEM' ESEM

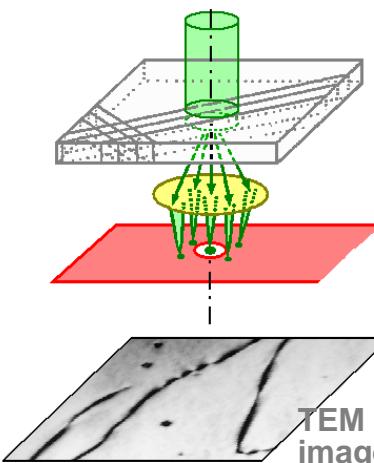


 **JEOL 2010F 200 kV**  
Tomo. TEM-HAADF

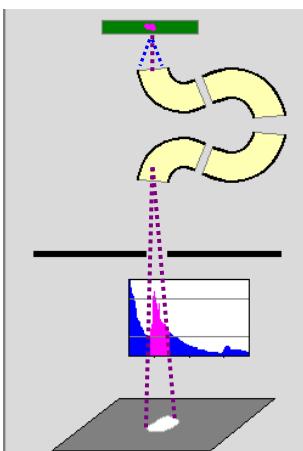
**(low-voltage STEM :  
Transmission mode in a SEM)**



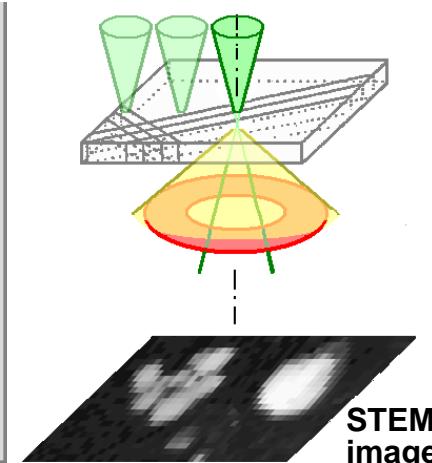
Conventional  
TEM



Energy-Filtered  
TEM



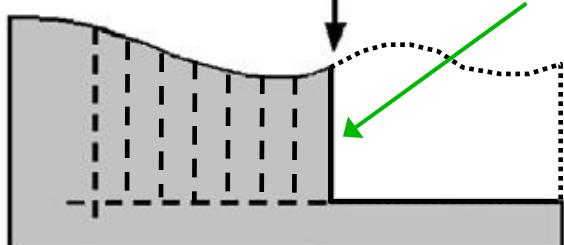
High Angle Annular  
Dark Field



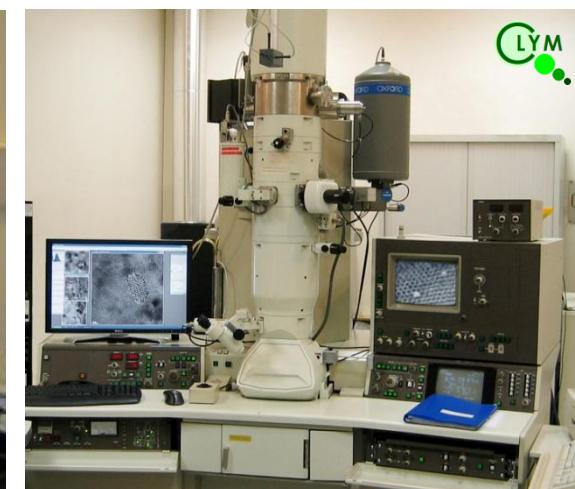
**'slice & view'  
in a FIB**

$\text{Ga}^+$

SEM  
observation



FEI XL30 30 kV  
Tomo 'STEM' ESEM

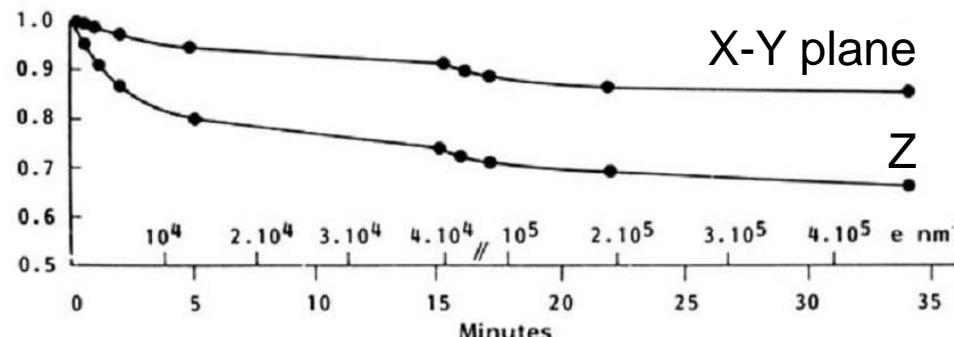


JEOL 2010F 200 kV  
Tomo. (EF)TEM-HAADF

## II. Polymers and charged particles

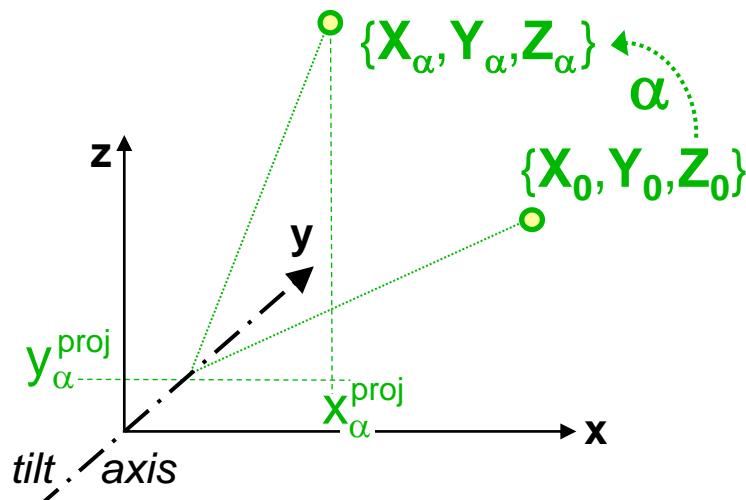
*Polymers don't like charged particles!*

### II.1 The shrinkage effect



[P.K. LUTHER, chap. 1 in *Methods for Three-Dimensional Visualization of Structures in the Cell*, Springer (2006)]

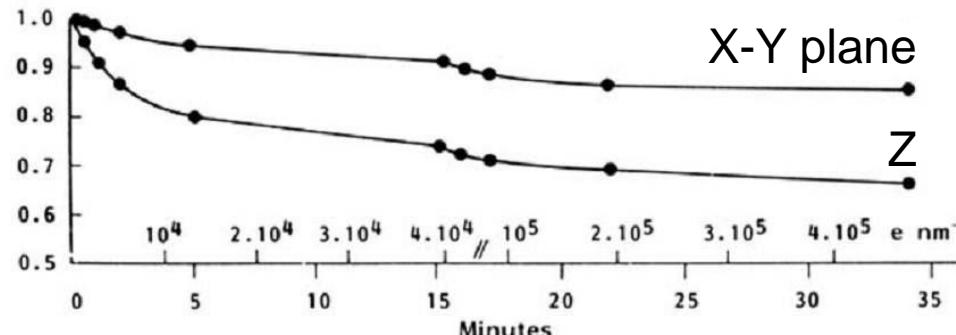
- *Rk.: shrinkage measurement: see 'late' poster Y. LIU et al.*



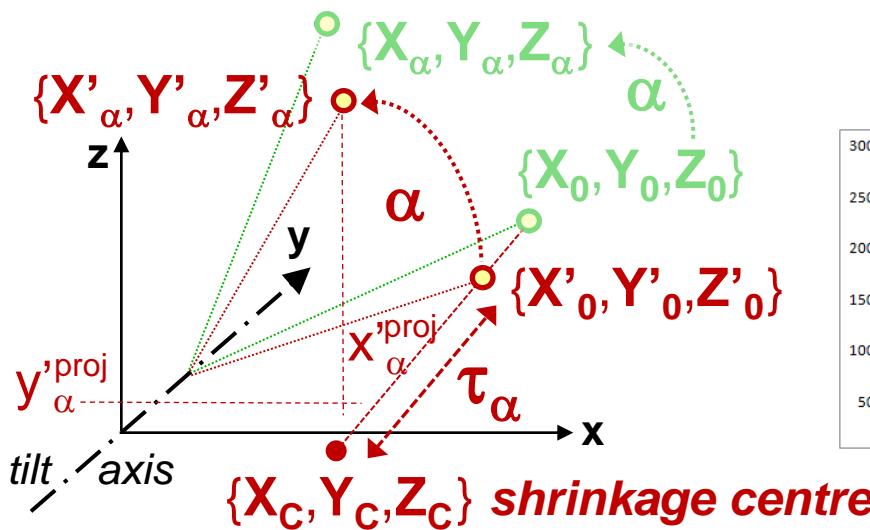
# II. Polymers and charged particles

*Polymers don't like charged particles!*

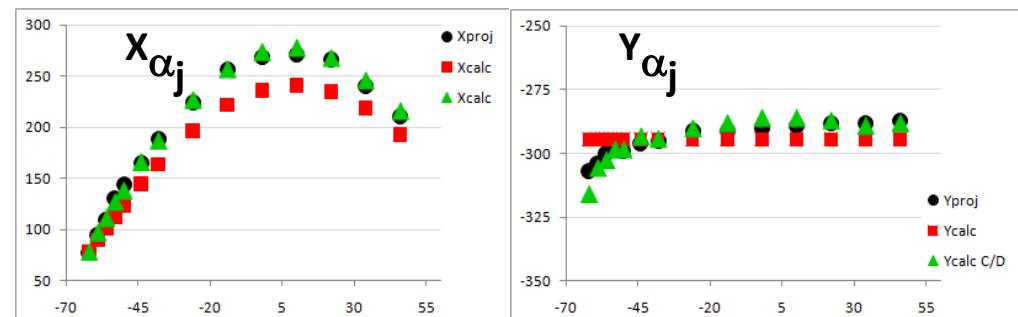
## II.1 The shrinkage effect



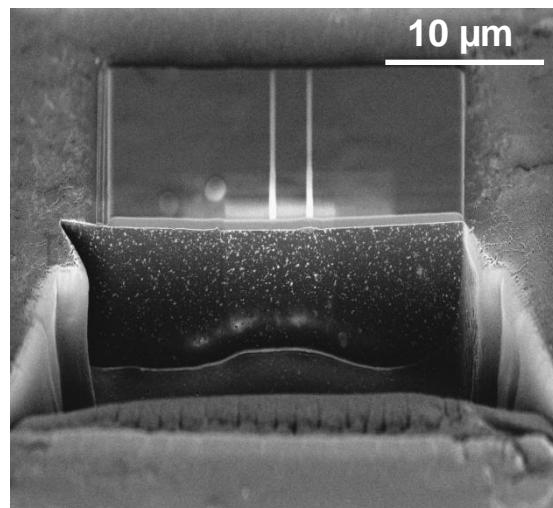
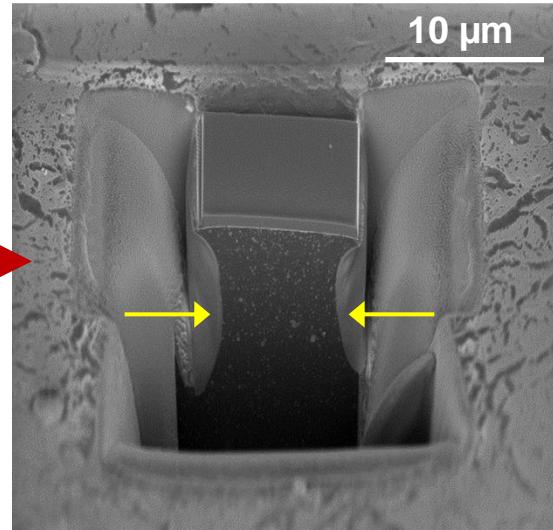
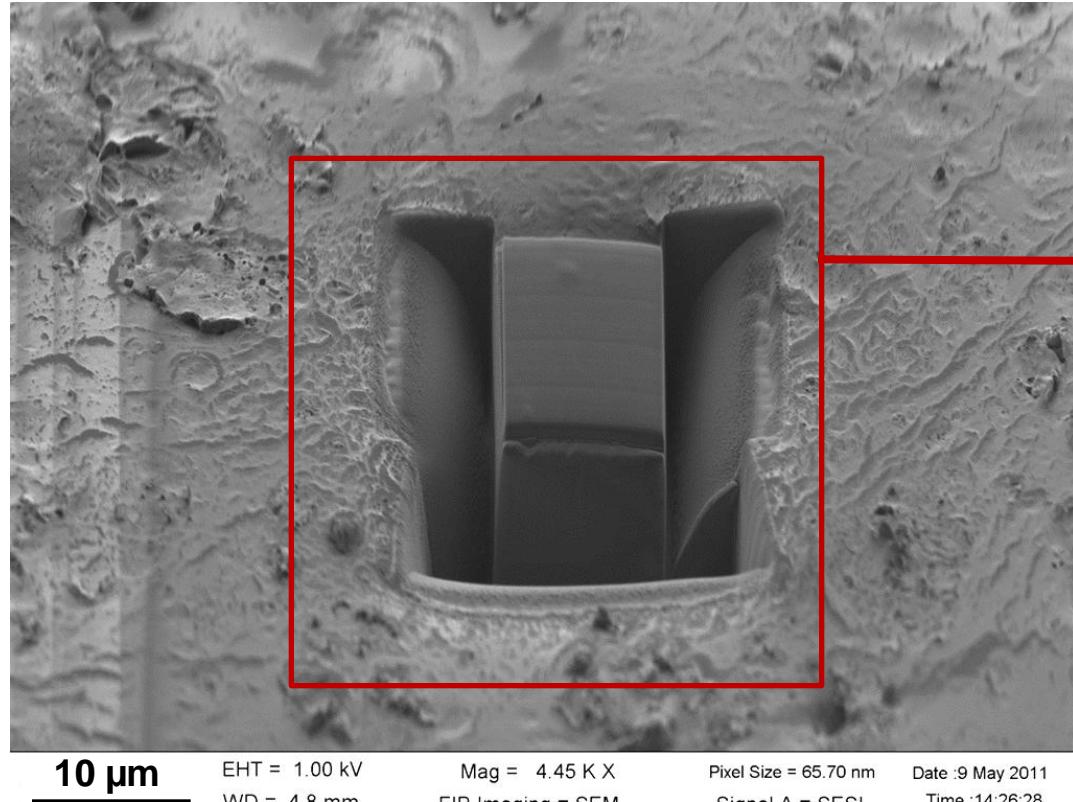
[P.K. LUTHER, chap. 1 in *Methods for Three-Dimensional Visualization of Structures in the Cell*, Springer (2006)]



- *Rk.: shrinkage measurement: see 'late' poster Y. LIU et al.*



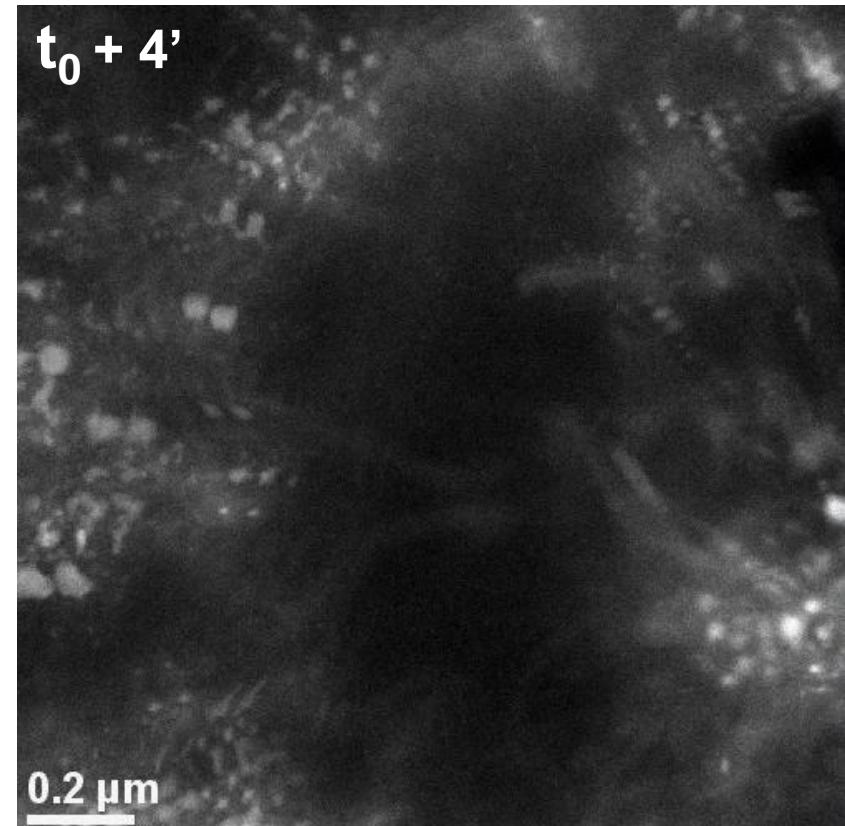
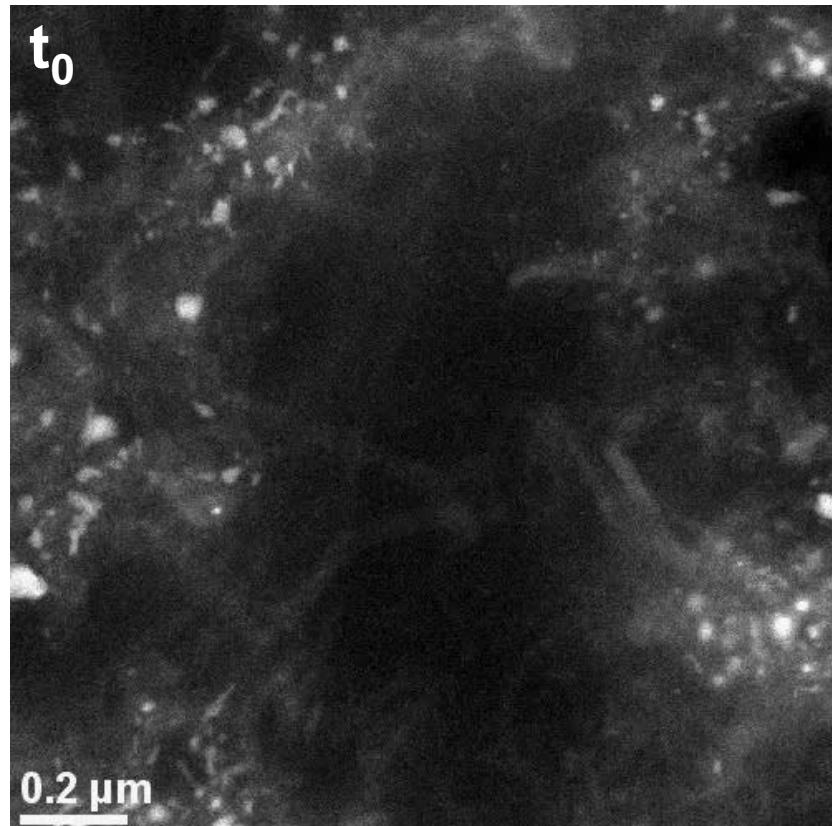
## Shrinkage during FIB observation PMMA/PBuA 1% SiO<sub>2</sub>, PH5



adopted geometry

## Shrinkage during TEM observation

CNTs@polymer - Poly(Styrene co-Butyl Acrylate) P(S-BuA) - nanocomposite



- See communication Y. LIU et al.

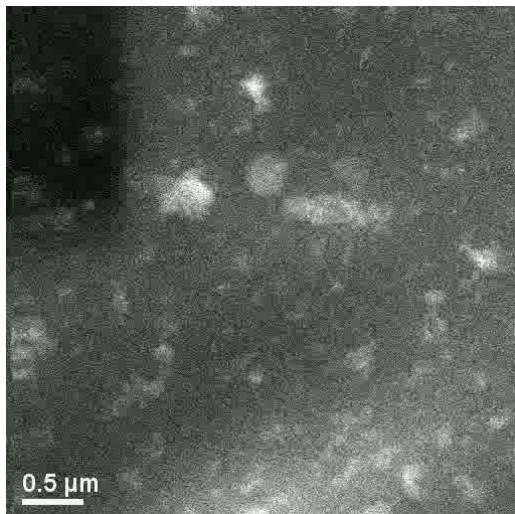
# II. Polymers and charged particles

*Polymers don't like charged particles!*

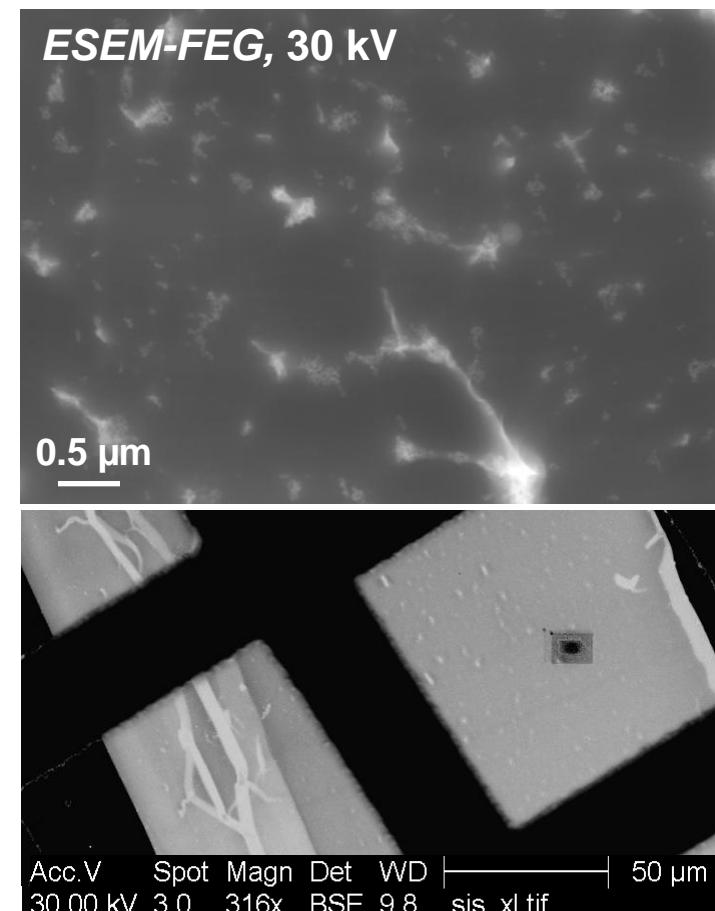
## II.2 Electron-induced mass-loss

PMMA/PBuA 1% SiO<sub>2</sub>, PH5

TEM 200 kV



STEM-HAADF  
speed x2

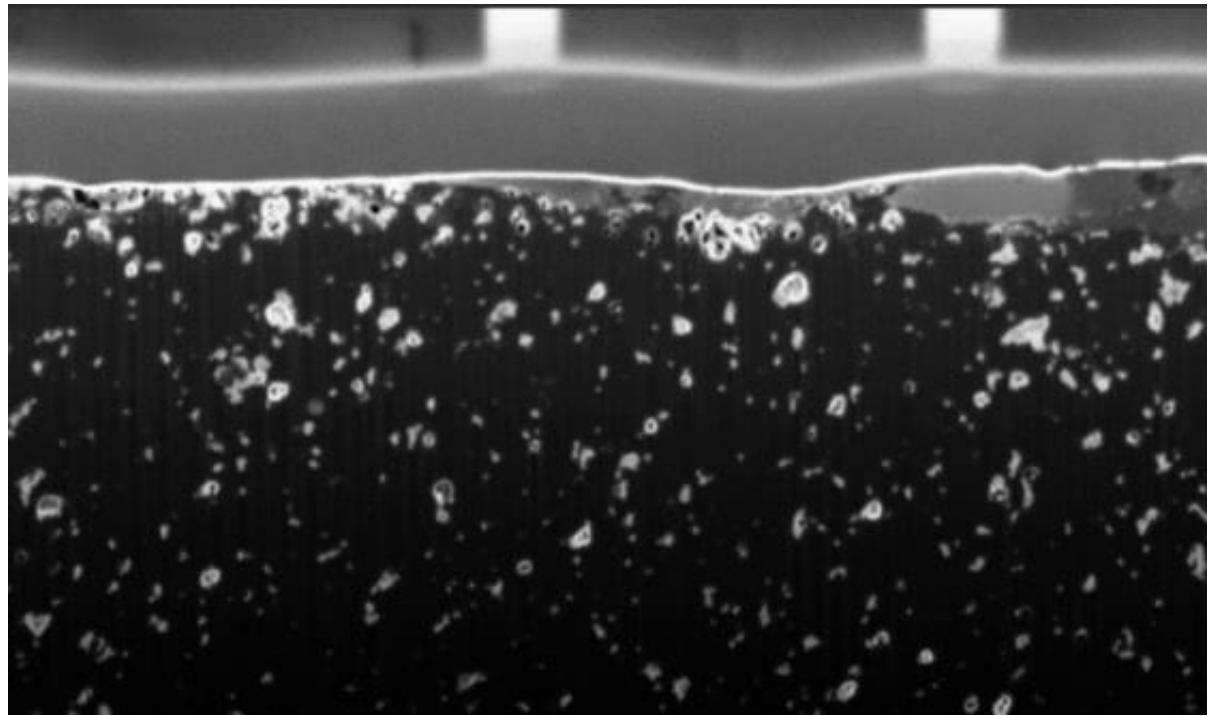


STEM in SEM

# III. A Tri-3D approach of polymer nanocomposites

## III.1 FIB tomography

PMMA/PBuA 1% SiO<sub>2</sub>, PH5



1 μm

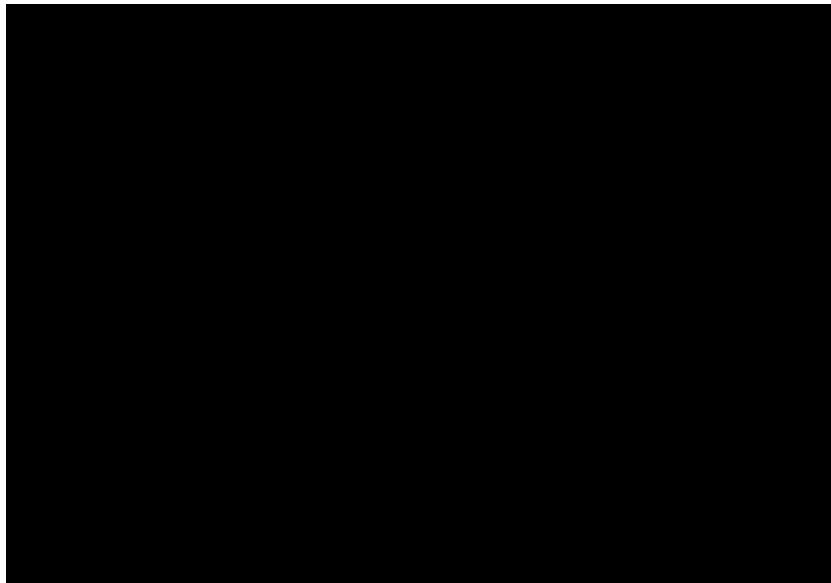
Typical sequence and depth/slice: 500 slices, 6 (to 10) nm

## Note: life / automatic correction of DRIFT

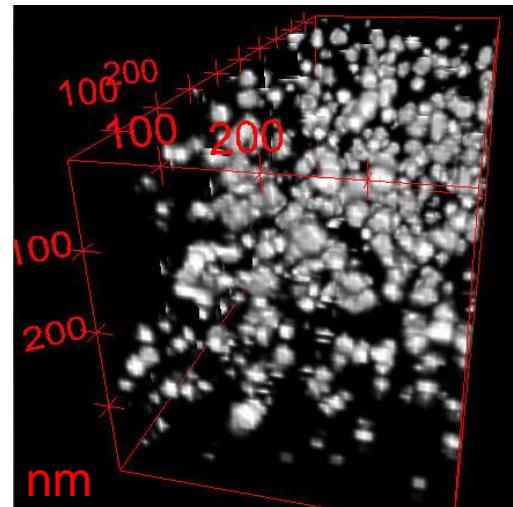
application (ZEISS API):

VB6 programming + Stackreg [P. Thévenaz et al., *IEEE Trans. on Image Proc.* 7, (1998) 27]  
procedure in FIJI (<http://fiji.sc/wiki/index.php/Fiji>)

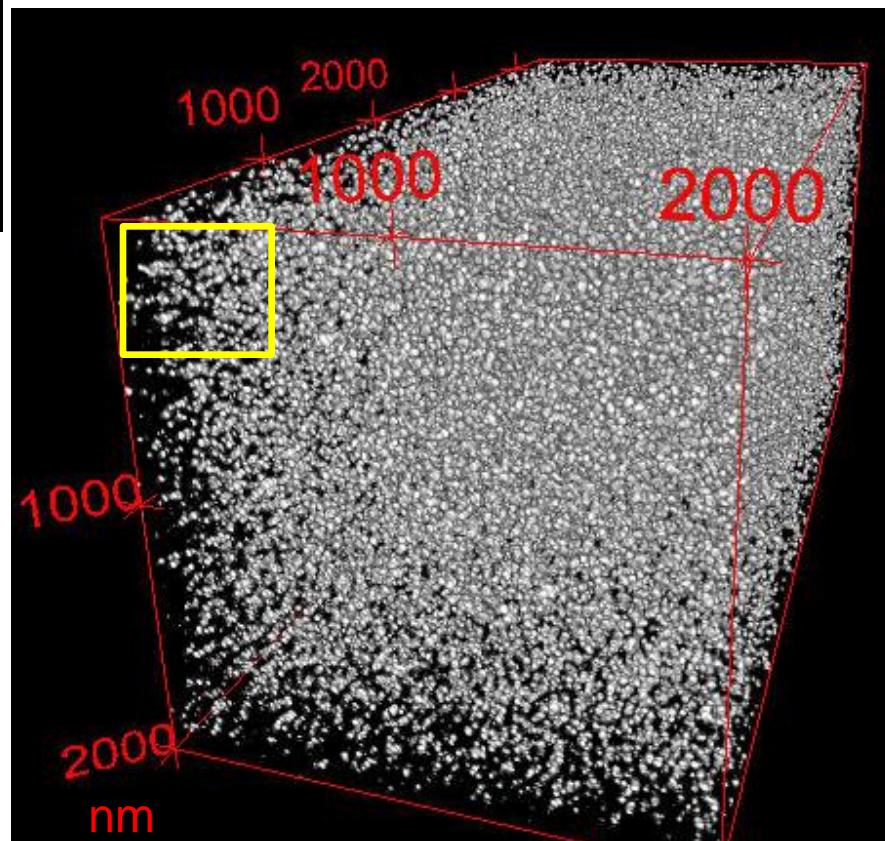
0.2 μm



- See poster H. YUAN et al.



$100^3$  voxels



segmented /  
erosion / dilation

500\*500\*454 voxels

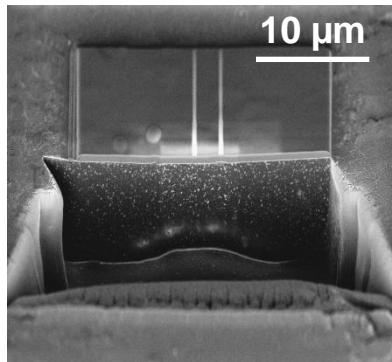
**voxel 4\*4\*10 nm**

$$\begin{aligned} F_{\text{SiO}_2} &= \\ V_{\text{SiO}_2} &/ V_{\text{total}} \\ \approx 4.9\% \end{aligned}$$

**Expected value:**  
**1 %** [M. TATOU,  
 PhD thesis, (2010)]

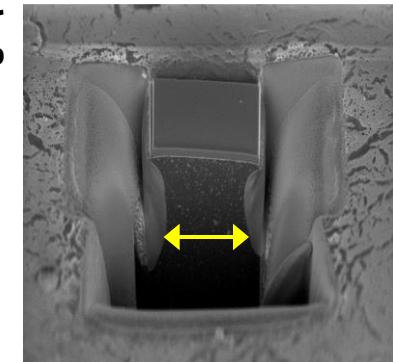
## ● Effect of the shrinkage?

Mostly avoided in FIB...

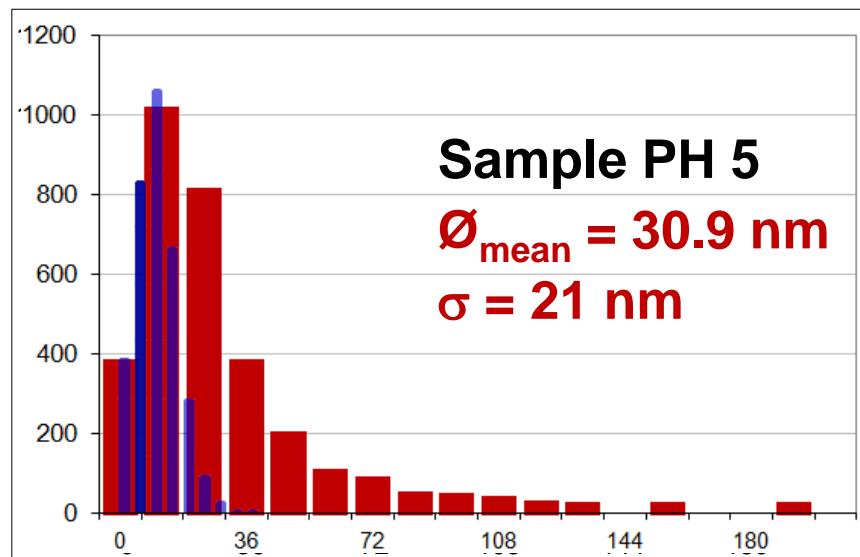
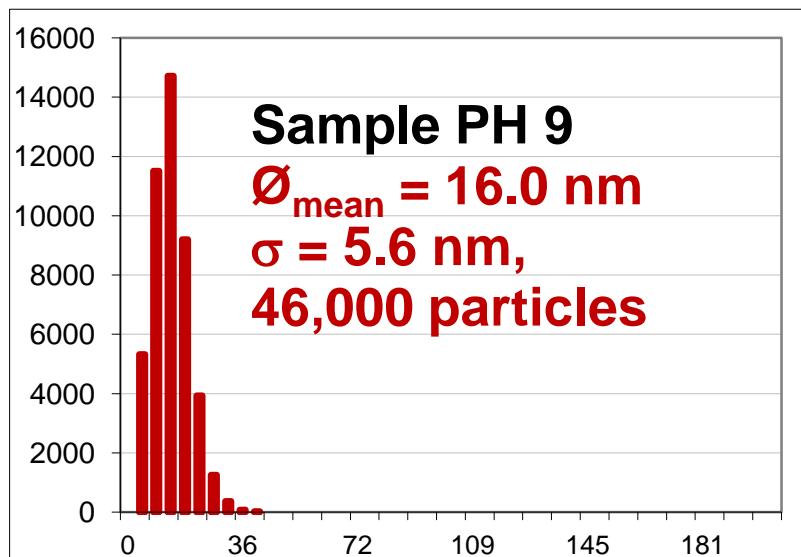


and effect  
less than ≈ 25%

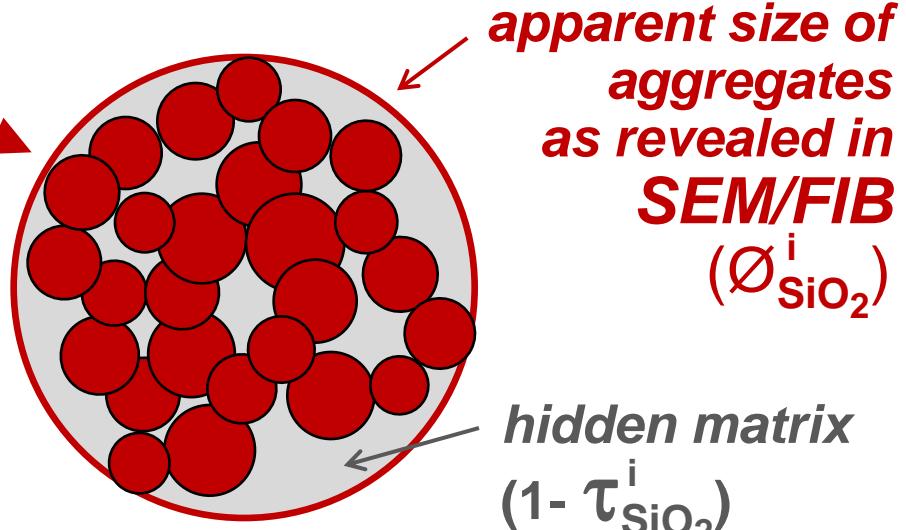
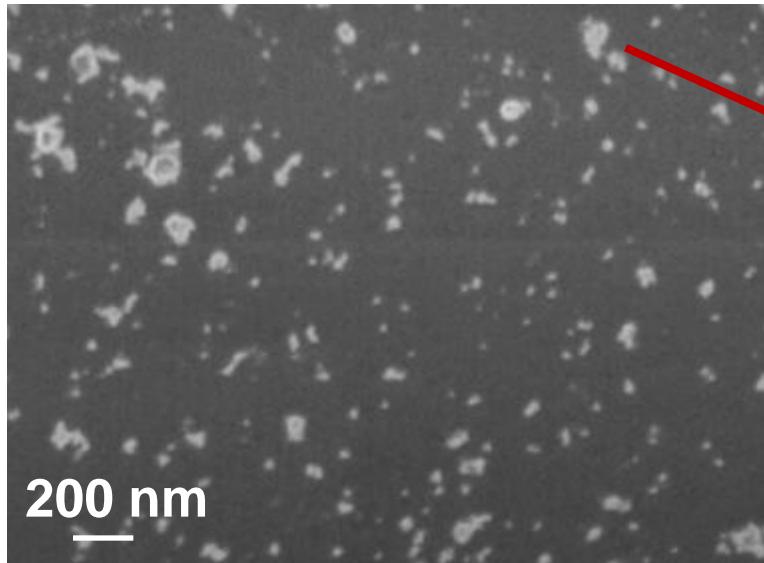
$F_{\text{SiO}_2} \approx 4.9\%$   
 $\approx 3.6\%$   
**Expected  
value 1 %**



## ● Structure of the particle aggregates?



SEM-FIB, 1 kV

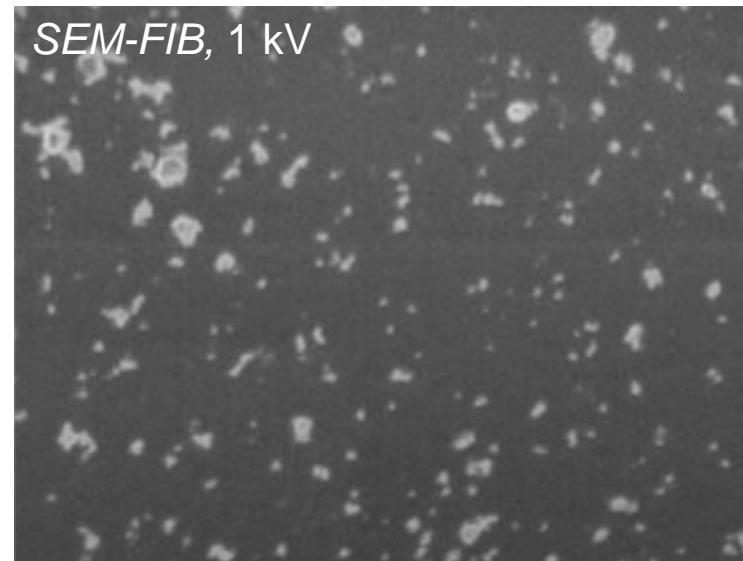
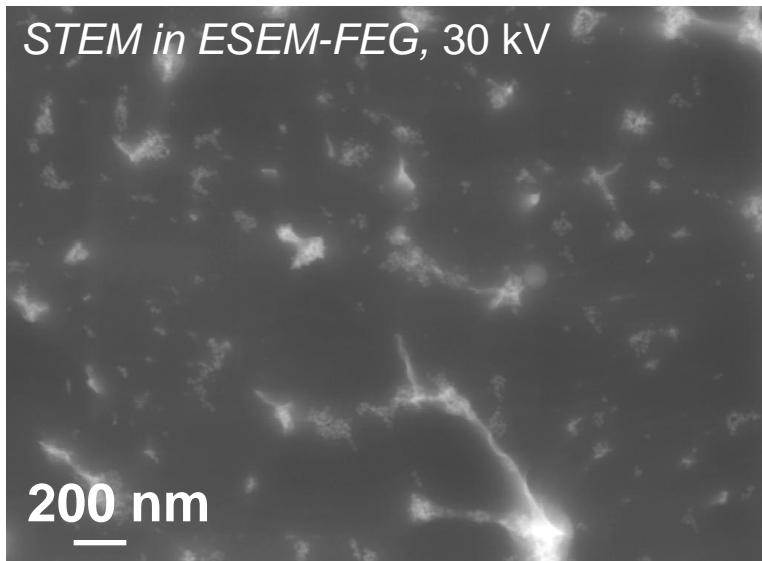


$$V_{\text{SiO}_2}^{\text{apparent}} = \sum 4\pi(\emptyset_{\text{SiO}_2}^i/2)^3/3 \quad \text{and} \quad F_{\text{SiO}_2}^{\text{apparent}} = V_{\text{SiO}_2}^{\text{apparent}} / V_{\text{total}}$$

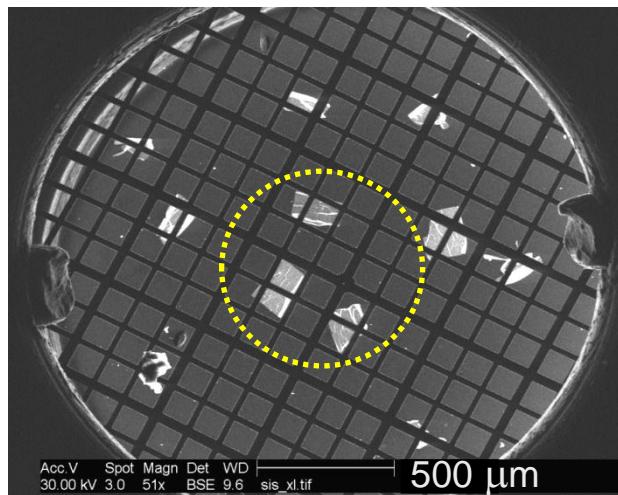
$$V_{\text{SiO}_2}^{\text{corrected}} = \sum \tau_{\text{SiO}_2}^i 4\pi(\emptyset_{\text{SiO}_2}^i/2)^3/3 \quad \text{and} \quad F_{\text{SiO}_2}^{\text{corrected}} = V_{\text{SiO}_2}^{\text{corrected}} / V_{\text{total}}$$

- NEED for higher resolution to measure the ratio of *hidden matrix*
  - tilting tomography in TEM
  - *tilting tomography in LOW VOLTAGE SEM?*

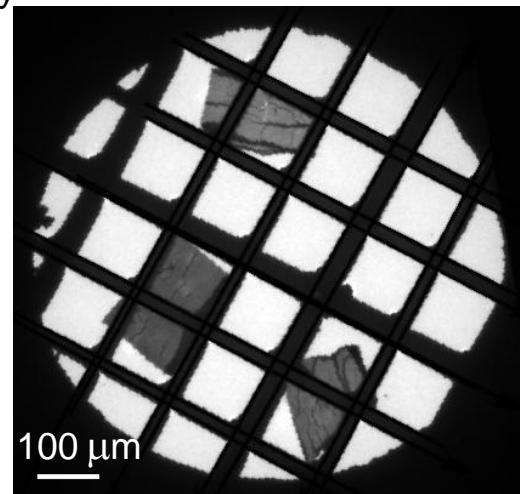
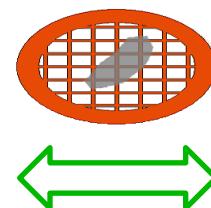
## III.2 Tilting tomography in LOW VOLTAGE STEM in a SEM



**STEM  
mode  
in a  
SEM**



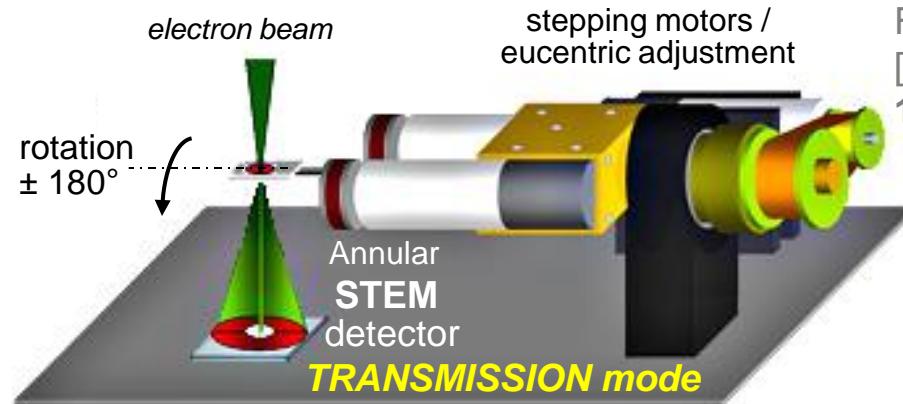
ultramicrotomy  
(50-200 nm)



**TEM  
BF  
mode**



 FEI XL30 30 kV  
ESEM

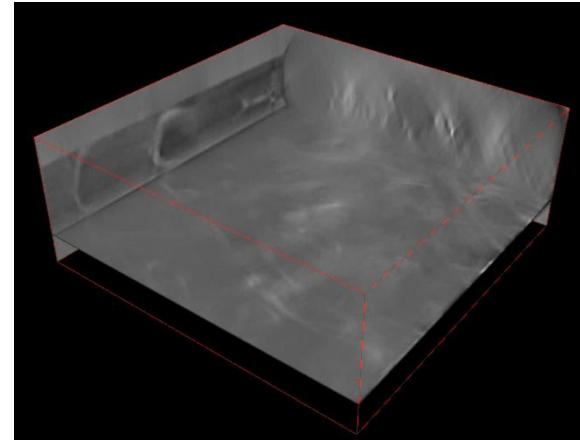
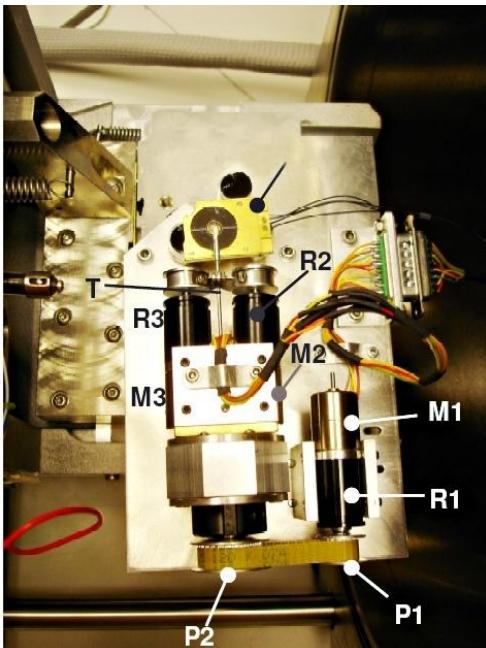


French PATENT FR06-09-708, (2006)  
 [P. JORNSANOH et al., *Ultramicrosc.*, 111, (2011), 1247-1254]

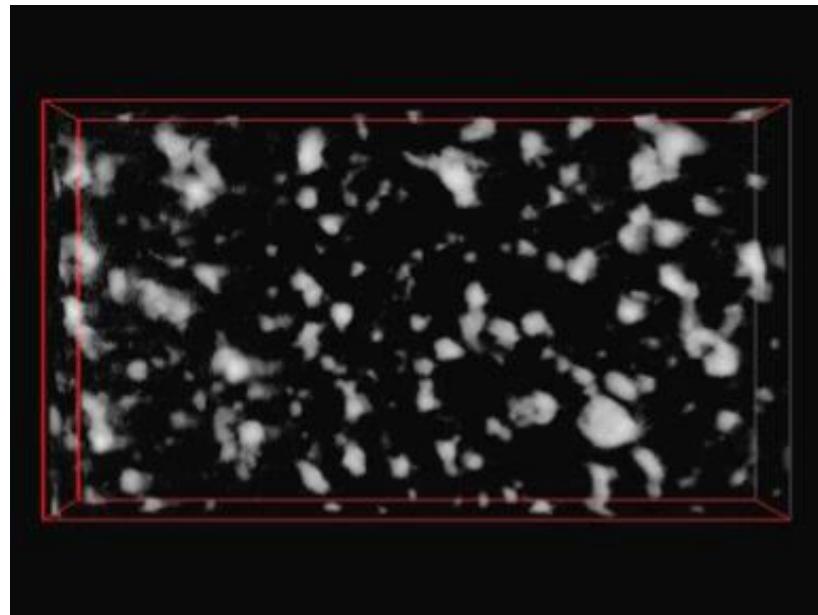
200 nm



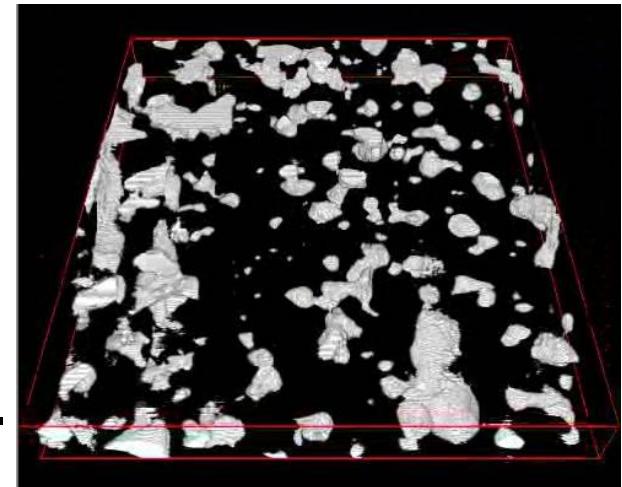
CNTs@P(S-BuA)



## PMMA/PBuA 1% SiO<sub>2</sub>, PH5



1 μm

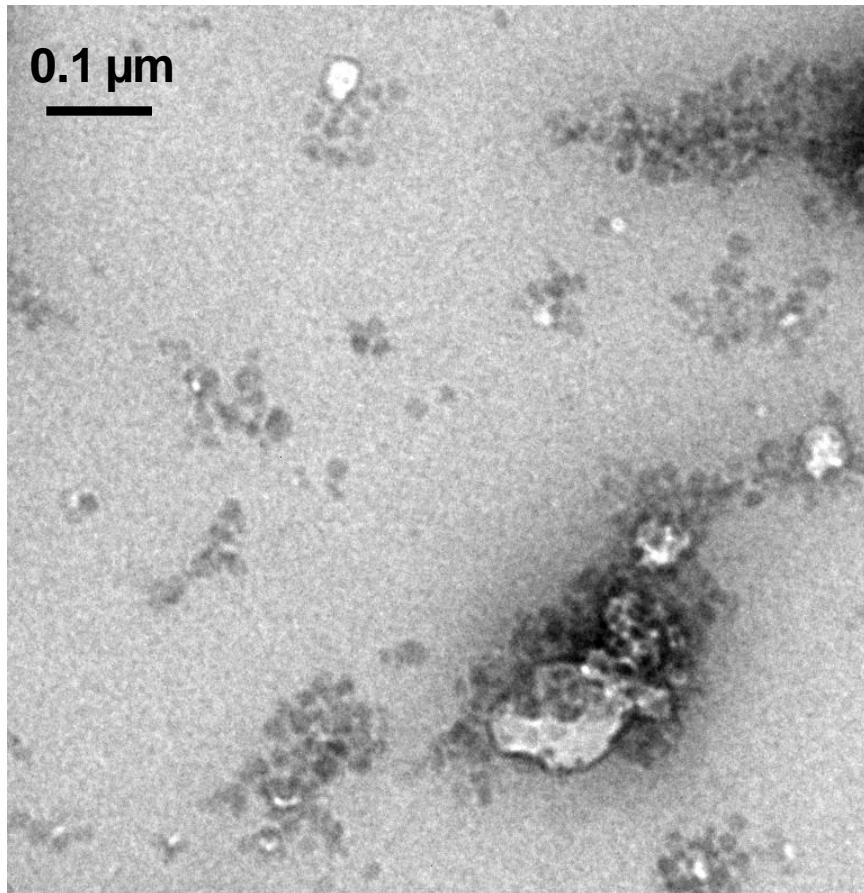


*Reconstruction from a tilted serie  
+40° / -40°, step 5°*

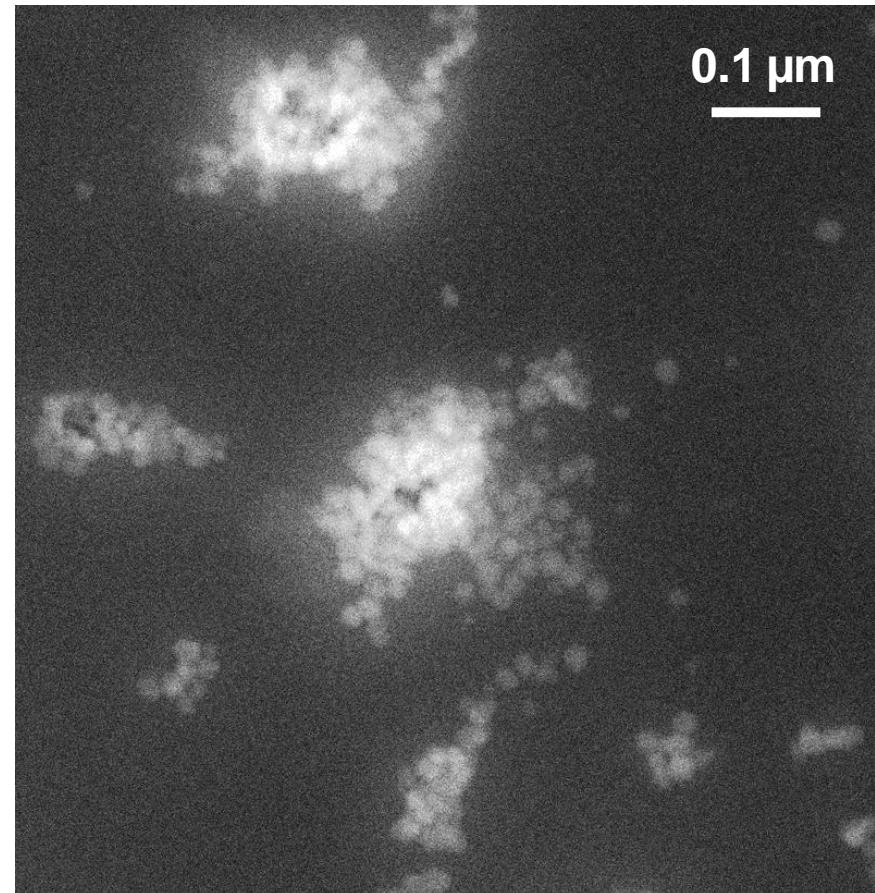
- NO improvement in the 3D resolution (internal structure of aggregates)

### III.3 Tilting tomography in TEM (200 kV)

*TEM BF mode*

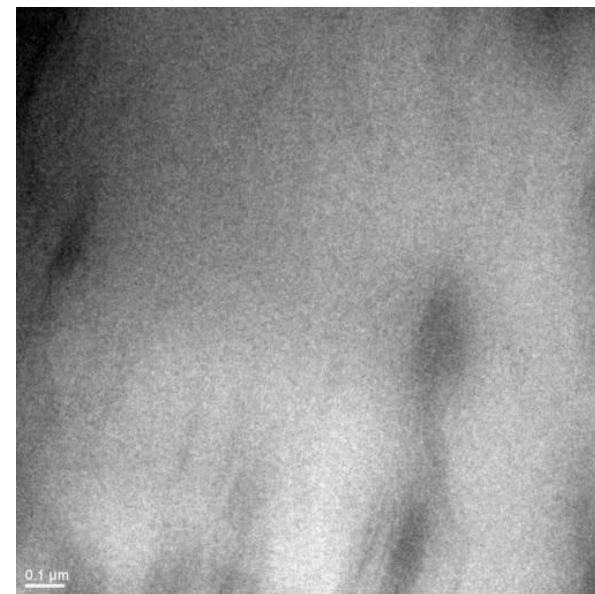
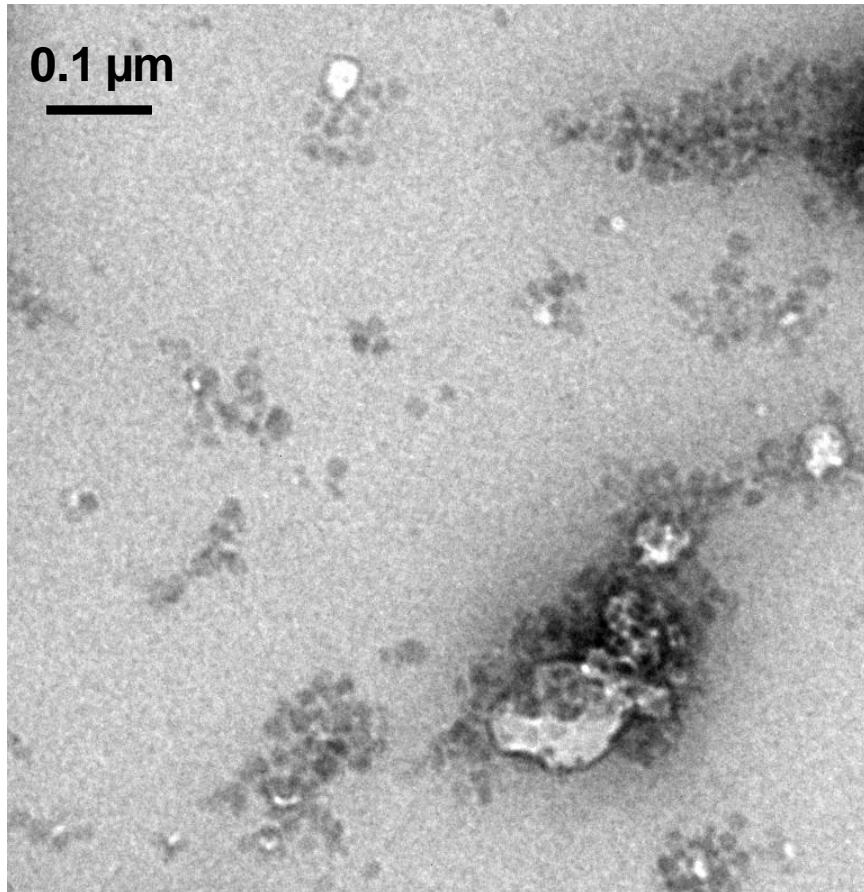


*STEM-HAADF*



### III.3 Tilting tomography in TEM

*TEM BF mode*

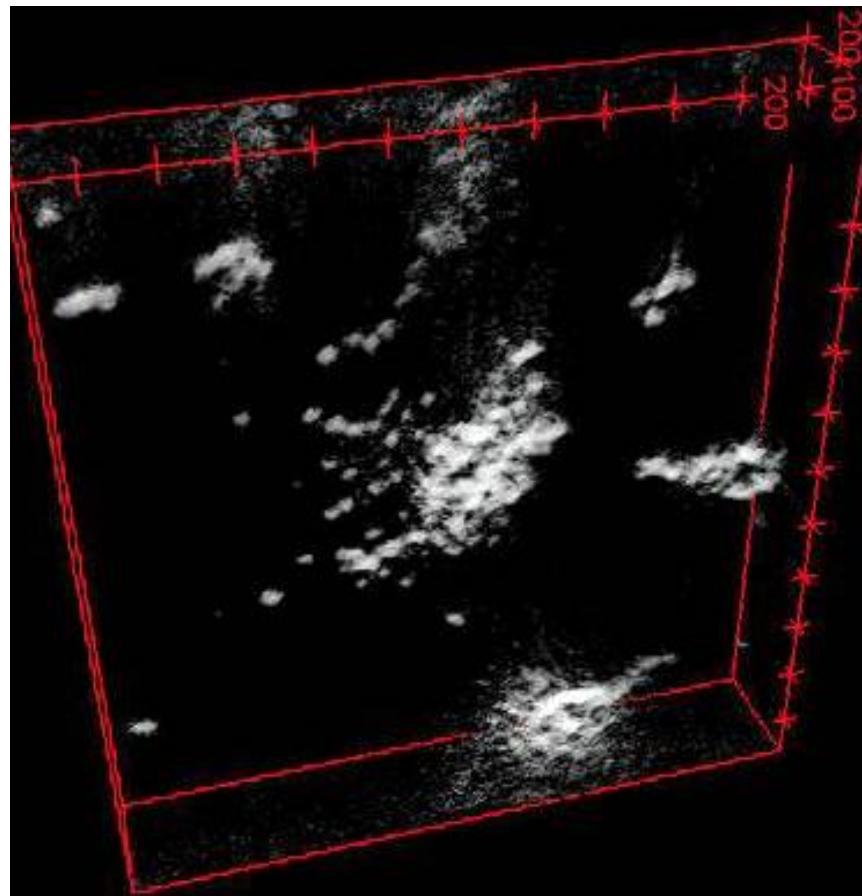


**CTEM**  
speed x2

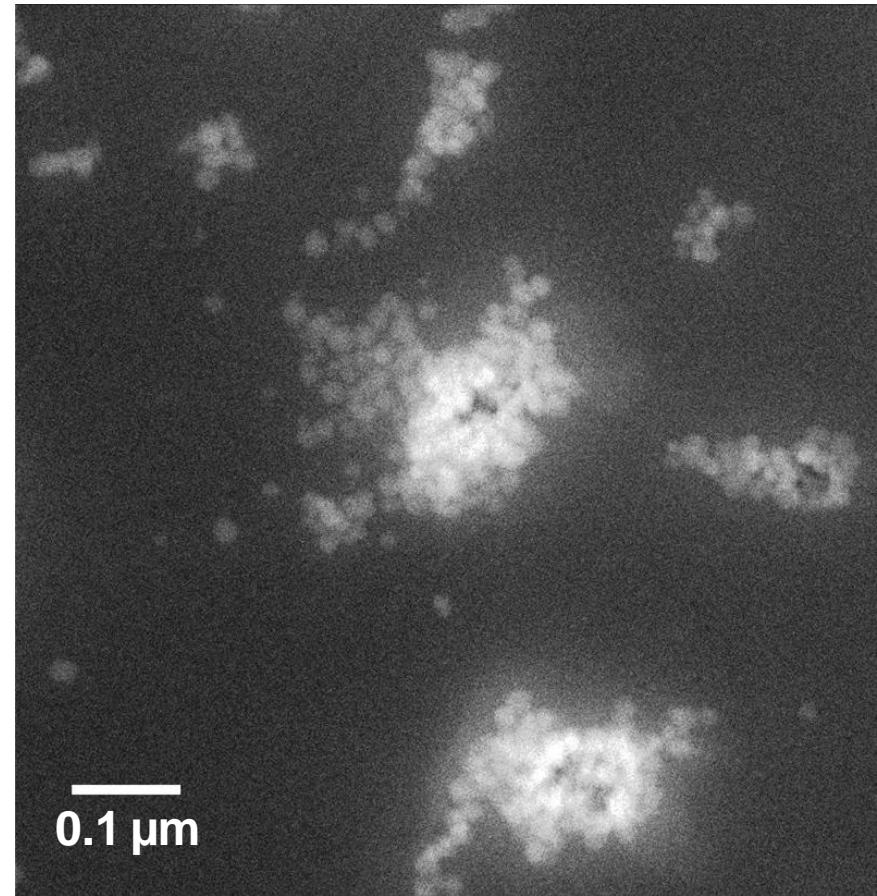
*irradiation-induced cavitation  
in aggregates*

### III.3 Tilting tomography in TEM

Tilted series , -58° / 30°, step 4°



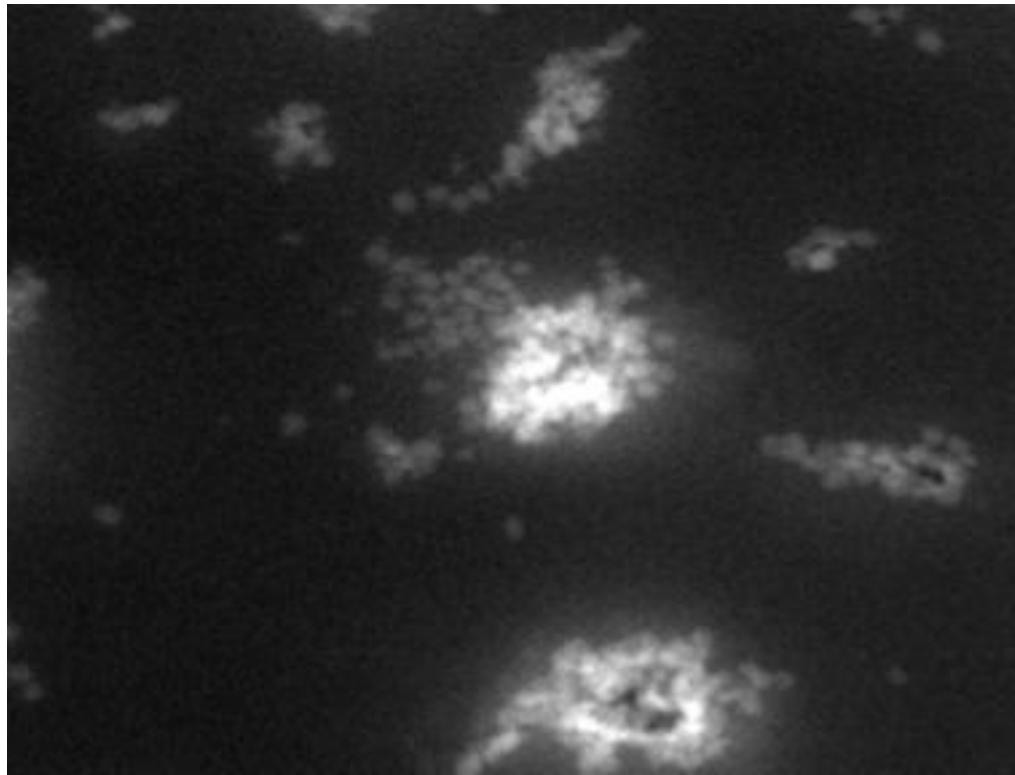
**STEM-HAADF**

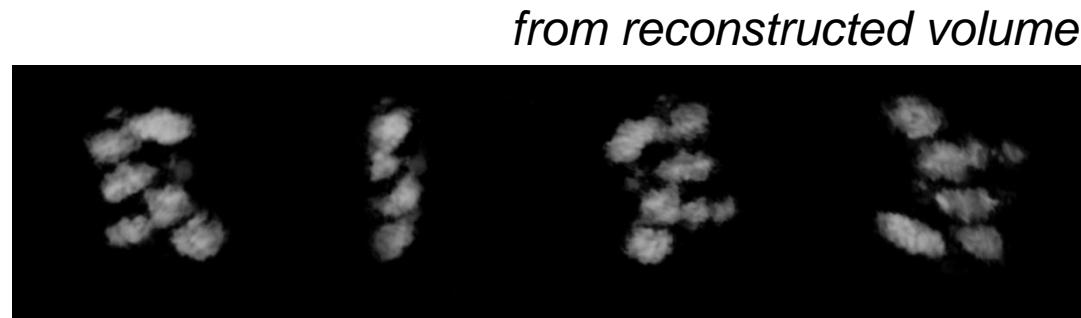
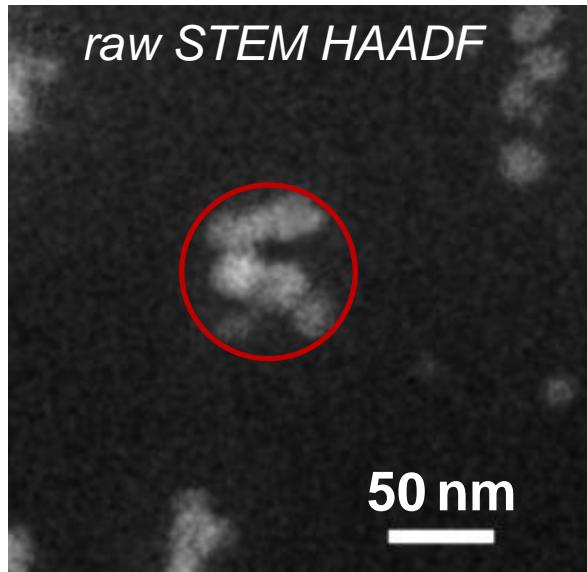


### III.3 Tilting tomography in TEM

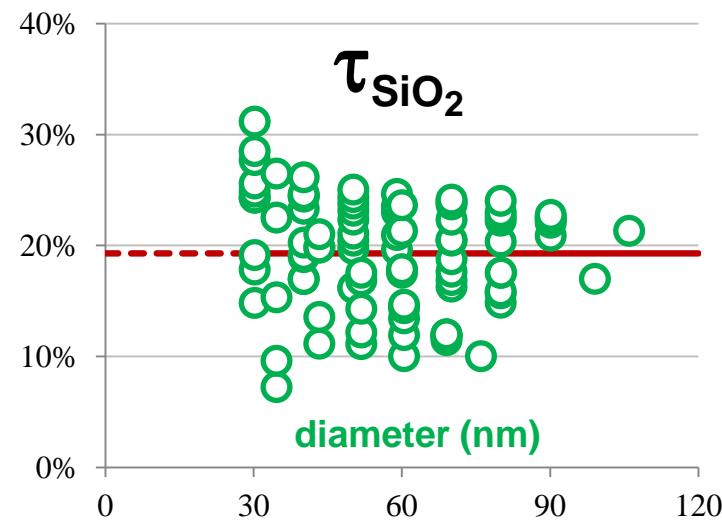
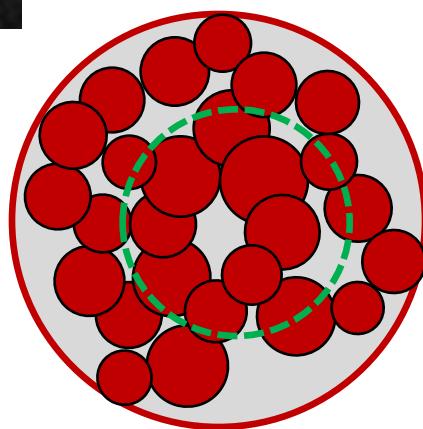
*Tilted series , -58° / 30°, step 4°*

0.1 μm





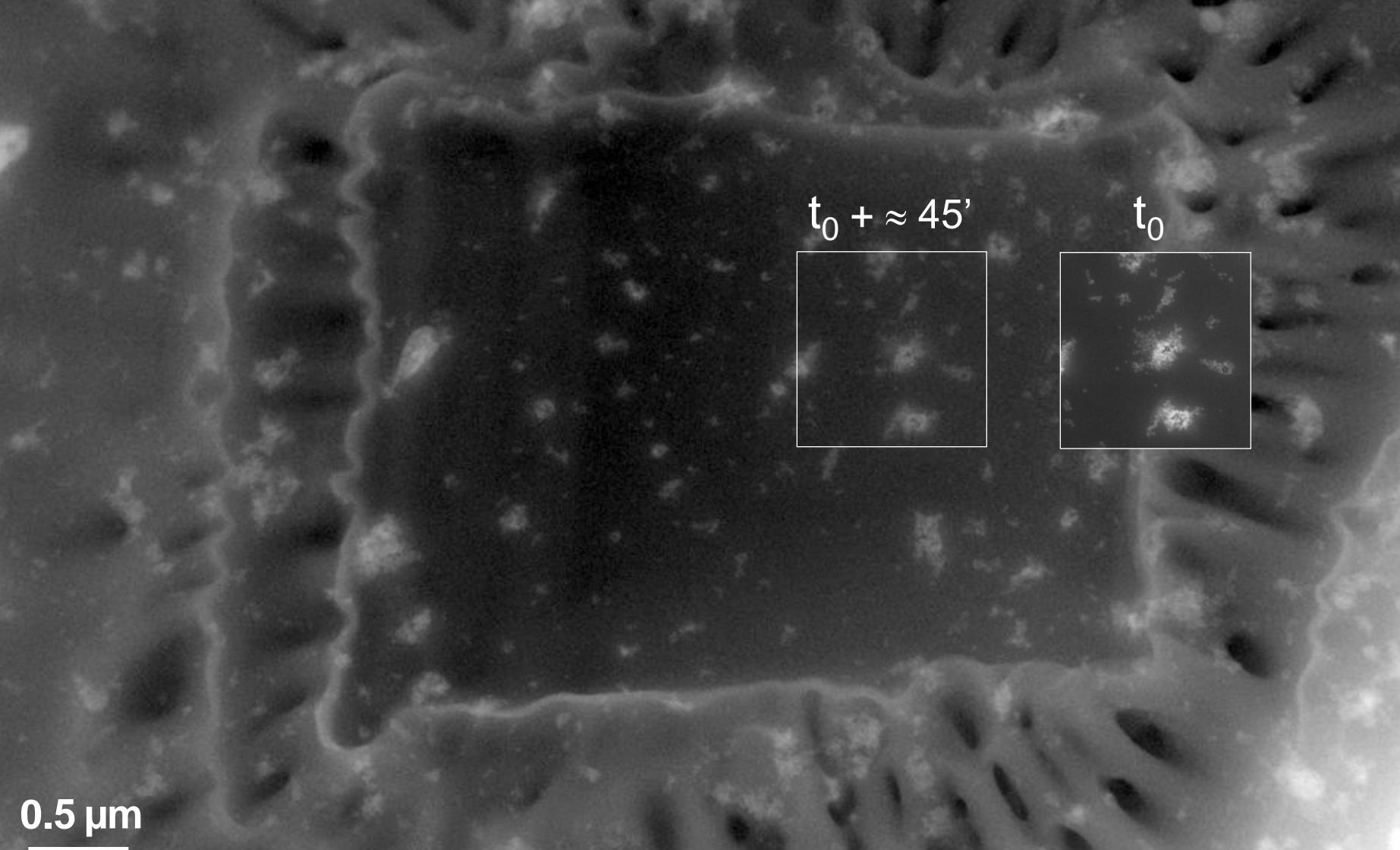
- Clear evidence for a low density  $\tau_{\text{SiO}_2}$  of NPs in aggregates



$$\tau_{\text{SiO}_2} \approx \text{Cst}^t = 20\% \pm 10\%$$

$$V_{\text{SiO}_2}^{\text{corrected}} \approx \tau_{\text{SiO}_2} V_{\text{SiO}_2}^{\text{apparent}} \text{ and } F_{\text{SiO}_2}^{\text{corrected}} = \tau_{\text{SiO}_2} F_{\text{SiO}_2}^{\text{apparent}} = 0.2 * 4.9\% \approx 1\% \pm 0.5\%$$

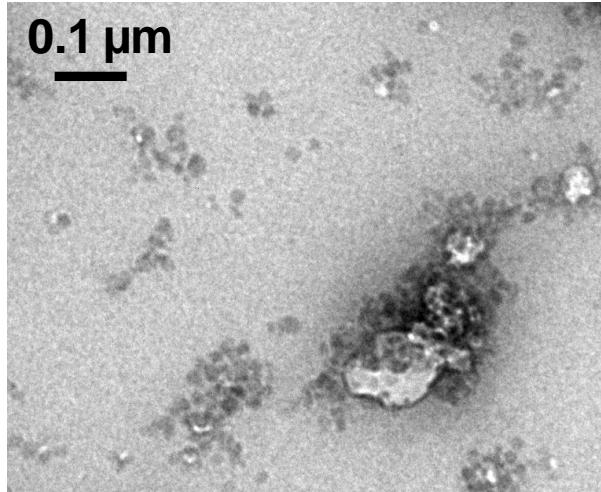
Note: degradation of the thin foil during the tilting acquisition



0.5  $\mu\text{m}$

# IV. Conclusion

- For the chemists in polymer science: nucleation of voids within the aggregates...



- Interest of coupling tomographic techniques at different and complementary scales (FIB / (SEM) / TEM)

- Complements to this approach:

- (i) communication Y. LIU on TEM tomography of CNTs@P(S-BuA) polymer nanocomposites
- (ii) posters H. YUAN et al. (live drift corrections in FIB 3D), Y. LIU et al. (quantification of shrinkage)

## Please apologize for this unusual conclusion...



**Agnès BOGNER-VAN DE MOORTELE**  
*our colleague, assistant–professor (MATEIS lab.)*  
*our co-author,*  
*our FRIEND*

passed away on Tuesday, February 28, just one week ago.  
She was only 35.

She has been fighting during 2 years against an unfair illness, with her youth, her kindness, her simplicity.

*It is just too sad.*

**Her husband, Bertrand VAN DE MOORTELE, is also**  
*our colleague, our co-author, our FRIEND.*

**We are just with him.**



# ACKNOWLEDGEMENTS

- plateform **CLYM** at *Lyon*  
for access to ZEISS NVision40, FEI XL30, JEOL 2010F microscopes



- **Thierry DOUILLARD, Nick BLANCHARD, Armel DESCAMPS-MANDINE**  
for taking care of the Nvision 40 FIB;  
**Pierre ALCOUFFE, Sylvie DESCARTES, Annie MALCHÈRE, Albert PERRAT, France SIMONET** for taking care of the XL30 ESEM-FEG;  
**Béatrice VACHER, Sophie CAZOTTES, Cyril LANGLOIS , A.M.**  
for taking care of the 2010 TEM-FEG



- **Jean-Claude MÉNARD** from **ZEISS S.A.S.** and **ZEISS S.A.S.** for financial support
- **Laboratoire des colloïdes, Verres et Nanomatériaux** (LCVN, Université de Montpellier, France) for providing the **PMMA/PBuA - SiO<sub>2</sub>** samples.

